

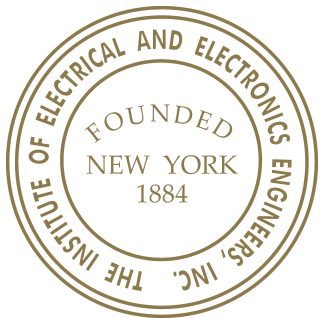


Transactions on Semiconductor Manufacturing
Steering Committee

Presents the
2022 T-SM Best Paper Award
To

Bei Yu

For the paper entitled "DeePattern: Layout Pattern Generation With
Transforming Convolutional Auto-Encoder," published in the IEEE
Transactions on Semiconductor Manufacturing
Volume 35, Number 1, February 2022



A handwritten signature in black ink, appearing to read "Reha Uzsoy".

Reha Uzsoy
TSM Editor-in-Chief

A handwritten signature in black ink, appearing to read "Peter Magnee".

Peter Magnee
Chairman, TSM Steering Committee

